

Trade Name Application of:

Examiner: *Lee, C.*

Art Unit: 2627

For: Document Surface Micro-Adjust Mechanism

COMMISSIONER FOR PATENTS
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AMENDMENT UNDER 37 CFR 1.114

A Request for Continued Examination (RCE) under 37 CFR 1.114 is made regarding the above-referenced patent application. Assignee respectfully requests that the Examiner enter the following amendment, which includes an amendment to the claims, and consider the following remarks.

Amendments begin on page 2.

Remarks begin on page 6.